

Appl. No. 10/762,676  
Amdt. Dated June 5, 2006  
Reply to Office Action of February 7, 2006

Attorney Docket No. 81872.0055  
Customer No.: 26021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Yosuke INOMATA

Serial No: 10/762,676

Confirmation No.: 5144

Filed: January 22, 2004

For: MULTICRYSTALLINE SILICON  
SUBSTRATE AND PROCESS FOR  
ROUGHENING SURFACE THEREOF

Art Unit: 1765

Examiner: Eric Brice Chen

I hereby certify that this correspondence  
is being transmitted via facsimile to  
(571) 273-8300;  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450 on

June 5, 2006

Date of Deposit

Diane Zynn

*Diane Zynn*

Signature

06/05/06  
Date

AMENDMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated February 7, 2006, the time for response to which is extended one month(s) by the accompanying petition from May 7, 2006 to June 7, 2006, please amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.